

Docket No.: 50006-073

**PATENT**

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of

Isao NOJIRI, et al.

Serial No.:

Filed: September 05, 2000

For: SEMICONDUCTOR DEVICE AND ITS WIRING METHOD

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Group Art Unit:

Examiner:

# 3/2DS  
10/31/00  
Sunder



**INFORMATION DISCLOSURE STATEMENT**

Assistant Commissioner for Patents  
Washington, DC 20231

Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the documents listed on the attached form PTO-1449. It is respectfully requested that the documents be expressly considered during the prosecution of this application, and that the documents be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

ial No.:

Each non-English language reference is accompanied by an English abstract.

Respectfully submitted,

MCDERMOTT, WILL & EMERY



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